

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jingyu Lian, et al.

Attorney Docket: 00P9119US

Filed: Herewith

Examiner: TBD

Serial No.: TBD

Art Unit: TBD

For: Multi-Layer Pt Electrode for DRAM and FRAM with High K Dielectric Materials

jc945 U.S. PTO
09/751551
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INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner For Patents

Washington, DC 20231

Dear Sir:

MAILING CERTIFICATE

I hereby certify that this correspondence is being deposited with the United States Postal Service as Express Mail No. _____ envelope addressed to: Assistant Commissioner for Patents, Washington, DC 20231.

Daniel G. Goff

12/28/00
Date

Applicants wish to bring to the attention of the Patent and Trademark Office the information noted on the enclosed PTO-1449 which may be considered material to the examination of the above identified application.

No fee is due at this time as this statement is being filed with the application.

Respectfully submitted,

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